

## 3D-PEIM 2020 Program

<b>Monday</b> <b>June 22, 2020</b> <b>8:00 – 10:15</b>	<b><u>S1 Plenary I Session – Chair: Prof. Tsuyoshi Funaki, Osaka, University</u></b> <ul style="list-style-type: none"> <li>• <b>“TBA”</b> by Yoshikazu Takahashi, Tohoku University, Japan</li> <li>• <b>“Electrification of Automobile and Activities of TOYOTA for Future Mobility”</b> by Dr. Keiji Toda, Toyota Motor Corporation, Japan</li> <li>• <b>“TBA”</b> by Hans-Juergen Albrecht, Dresden University, Germany</li> </ul>
<b>12:15 – 1:00</b>	<b><u>Lunch &amp; Networking</u></b>
<b>1:00-1:15</b>	<b><u>Opening Remarks by Symposium General Chair, Prof. Tsuyoshi Funaki, Osaka University</u></b>
<b>1:15 – 2:55</b>	<b><u>S2: Additive Manufacturing - Chairs: Patrick McCluskey, University of Maryland, USA and Douglas Hopkins, North Carolina State University, USA</u></b> <ul style="list-style-type: none"> <li>• <b>Keynote: “ Developments of high power blue diode laser systems for laser metal deposition and selective laser melting in additive manufacturing”</b> by Masahiro Tsukamoto, Joining and Welding Research Institute, Osaka University</li> <li>• <b>Invited: “TBA”</b> by Dirk Busse, Budatec GmbH, Berlin, Germany</li> <li>• <b>Invited: “A low inductive power system in package with multilayer ceramic substrate and integrated active cooling”</b> by Olivier Mathieu, Rogers Corp. – Power Electronics Solutions, Germany</li> <li>• <b>Invited: “Additive Manufacturing of High-aspect-ratio Ferrite Inductor Using an UV-curable Magnetic Feedstock”</b> by Guo-Quan Lu, Virginia Tech, USA</li> </ul>
<b>2:55 – 3:25</b>	<b><u>Break &amp; Networking</u></b>
<b>3:25 – 5:05</b>	<b><u>S3 System Integration &amp; Thermal Management - Chair: Christina DiMarino, Virginia Tech, USA</u></b> <ul style="list-style-type: none"> <li>• <b>Invited: “Opportunities and challenges of integrated WBG power electronics development”</b> by Alberto Castellazzi, Kyoto University, Japan</li> <li>• <b>Invited: “Thermal Solution for Cooling of Electronic Equipment using Lotus-type Porous Copper Heat Sink”</b> by Takuya Ide (Author), Lotus Thermal Solutions, Japan, Tetsuro Ogushi (Co-Author and presenter), Lotus Thermal Solutions, Japan</li> <li>• <b>Invited: “TAPIR (compact and modular Power modules with IntegRated cooling) technology: goals and challenges”</b> by Yvan Avenas, Grenoble University, France</li> <li>• <b>Invited: “Inevitability of Near Chip-Scale High Power GaN &amp; SiC Packages Replacing Even New WBG Traditional Modules”</b> by Courtney Furnival, Semiconductor Packaging Solutions (Author), USA, presented by Arnold Alderman, Anagenesis, USA</li> </ul>
<b>Tuesday</b> <b>June 23, 2020</b> <b>8:00 – 10:15</b>	<b><u>S4 Plenary II – Chair: Katsuaki Suganuma, Sanken Osaka University, Japan</u></b> <ul style="list-style-type: none"> <li>• <b>“Diamond Device”</b> by Toshiharu Makino, AIST, Japan</li> <li>• <b>“Applications with SiC Power Devices for Railcar”</b> by Tsuyoshi Tanaka, Mitsubishi Electric, Japan</li> </ul>
<b>10:15 – 10:45</b>	<b><u>Break &amp; Networking</u></b>
<b>10:45 – 12:30</b>	<b><u>S5 Multiphysics Design and Tools - Chair: Michihiro Shintani, Nara Institute of Science and Technology (NAIST), Kansai Science City, Japan</u></b> <ul style="list-style-type: none"> <li>• <b>Keynote: “TBA”</b></li> <li>• <b>Invited: “TBA”</b> Charlotte Blair, ANSYS, USA</li> <li>• <b>Invited: “Lifetime prediction simulation system for the next generation power semiconductor module using silver sintering die attach”</b> by Kenihi Oura, Advanced Simulation of Mechanics (ASTOM), Japan</li> <li>• <b>Invited: “Electrical-thermal modeling and simulation for SiC power MOSFET”</b> by Michihiro Shintani, NAIST, Japan</li> </ul>
<b>12:30 – 1:30</b>	<b><u>Lunch &amp; Networking</u></b>
<b>1:30 – 3:15</b>	<b><u>S6 Materials – Chair: Jason Rouse, Sekisui America, USA</u></b> <ul style="list-style-type: none"> <li>• <b>Keynote: “Superior reliability of power electronic packages with Die Top Systems (DTS®). Why a wire based technology solution outperforms clip based interconnections”</b> by Michael Joerger, Heraeus Electronics, Germany</li> <li>• <b>Invited: “Novel low-temperature copper sintering paste for die bonding at 200 °C in nitrogen atmosphere”</b> by Takanori Kobatake, Daicel Corporation, Japan</li> <li>• <b>Invited: “Space Charge Accumulation Properties in Various Insulating Materials for Power Electronics under DC High Electric Field at High Temperature”</b> by Ryo Miyake, Tokyo City University, Japan</li> <li>• <b>Invited: “Compatibility Assessment of Soft magnetic Metal-flake Composite Material for PCB embedding”</b> by Keitaro Tanno, Tokin Corporation, Japan</li> </ul>
<b>3:15 – 3:45</b>	<b><u>Break &amp; Networking</u></b>
<b>3:45 – 5:30</b>	<b><u>S7 Manufacturing Technologies - Chairs: John Bultitude, Kemet Corporation, USA</u></b> <ul style="list-style-type: none"> <li>• <b>Keynote: “The Technology Race in Power Electronics Packaging: A Rolling Start?”</b>, by Rainer Frauwallner, AT&amp;S, Austria</li> <li>• <b>Invited: “Cavity Propagation under Pulse Voltages in Silicone Gel for Encapsulation of Power Modules”</b> by Akiko Kumada and Moritoshi Sato, University of Tokyo, Japan</li> <li>• <b>Invited: “Lost-foam technology for power electronics packaging”</b> by Thomas Lei, Nio Electric Car, Shanghai China</li> <li>• <b>Invited: “Advanced Photonic Curing: High-Speed Printing and soldering with light”</b> by Kurt Schroder, NovaCentrix, USA</li> </ul>
<b>6:00 – 8:00</b>	<b><u>Networking Reception, poster session, vendor exhibits, with dinner</u></b>
<b>Wednesday</b> <b>June 24, 2020</b> <b>8:00 – 10:00</b>	<b><u>S8: Quality &amp; Reliability – Chair: Steven Martell, Nordson Sonoscan, USA</u></b> <ul style="list-style-type: none"> <li>• <b>Keynote: “Reliability aspects of 3D integrated power devices”</b> by Josef Lutz, Technical University of Chemnitz, Germany</li> <li>• <b>Invited: “Thermal Performance and Reliability Study on Major Designs and Packaging Process of Automobile Power Module”</b> by Quiang Yu, Yokohama National University, Japan</li> <li>• <b>Invited: “Quality Assurance of 3D Power Device Structures with Non-Destructive Imaging Techniques”</b> by Steven Martell, Sonoscan – Nordson Electronic Solutions, USA</li> <li>• <b>Invited: “Quality and reliability assurance of vacuum conduction soldering processes with big data approaches”</b> by Aaron Hutzler, Bond Pulse, Germany</li> </ul>
<b>10:00 – 10:30</b>	<b><u>Break &amp; Networking</u></b>
<b>10:30 – 12:30</b>	<b><u>S9 Sponsors Session - Chair: Minora Ueshima, Daicel, Japan</u></b> <ul style="list-style-type: none"> <li>• <b>Sponsors Round Table Discussion:</b></li> </ul>
<b>12:30 – 1:30</b>	<b><u>Lunch &amp; Networking</u></b>
<b>1:30 – 3:15</b>	<b><u>S10: Heterogeneous Integration - Chair: Cyril Buttay, Laboratoire Ampère, France</u></b> <ul style="list-style-type: none"> <li>• <b>Keynote: “Development of High Performance SiC Power Module”</b> by Hiroshi Yamaguchi, National Institute of Advanced Industrial Science and Technology (AIST), Japan</li> <li>• <b>Invited: “3D Power Electronics by Embedding of Components into the Build-up of Printed Circuit Boards: 2 Case Studies”</b> by Thomas Löher, Fraunhofer IZM Germany</li> <li>• <b>Invited: “Flexible Integration Of High Power Modules By Means Of IC-Embedded Sub-Modules”</b> by Jean-Marc Yannou, ASE Group, France</li> <li>• <b>Invited: “Resumption of contacts by metallic foam Electrical, thermal and reliability performance”</b> by Mickaël Petit, SATIE Laboratory, France</li> </ul>
<b>3:45 – 5:45</b>	<b><u>Networking &amp; Lab Tours – Osaka University</u></b>

TBA = To be announced